



International Journal of ChemTech Research

CODEN (USA): IJCRGG ISSN: 0974-4290 Vol.7, No.5, pp 2532-2536, 2014-2015

Optical and electrical properties of ZnO:Al thin films synthesized by low cost spray pyrolysis

C. Rameshkumar¹, R. Subalakshmi²

¹Department of Physics, Sathyabama University, Chennai, Tamilnadu– 600 119, India ²Department of Physics, University of Madras, Chennai, Tamilnadu - 600 005, India

Abstract: Undoped and aluminum-doped ZnO thin films are prepared by ultrasonic spray pyrolysis at 400 $^{\circ}$ C on glass substrates were investigated. In this preparation Zinc acetate dihydrate is used as precursor, methoxyethanol is used as solvent and mono-ethanolamine is used as stabilizer. The dopant solution is taken at the atomic percentage of 1 to 5. The electrical and optical properties of ZnO films were investigated when Al is doping on ZnO. It is compared to pure ZnO thin film, the grain size in the Al-doped thin film. A 2 at.-% of Al doped with the thin film a minimum resistivity of $3.3 \times 10^{-3}\Omega$ -cm was obtained and carrier concentration as high as 5.52×10^{19} cm⁻³. For pure ZnO, the value of bandgap is 3.229 eV and it increases to 3.29 eV in 1at.-% of Al doped ZnO. The bandgap value decreases, when 2 at.-% of Al doped in ZnO film. The increase in bandgap can be explained by the Burstein –Moss effect.

Keywords: Electrical Properties ZnO:Al, thin films low cost spray Pyrolysis.

Introduction

Generally pure ZnO is an *n*-type semiconductor. But its electrical and optical properties seem to be not very stable, especially at high temperatures. For practical purposes, doped *n*-type ZnO is usually preferred. Doped ZnO thin films have been extensively studied because of its various properties, such as ultraviolet photo detectors, blue and ultraviolet light emitters, gas sensors, surface acoustic devices, liquid crystal displays, photovoltaic devices, heat mirrors, multi layer photo conversion layers, transparent electronics, solar cells and catalysers, etc. In the form of thin film, ZnO is a very potential alternative in flat display screens compared to tin-doped indium oxides (ITO) which is a delineate natural resource. When it is doped with Al, ZnO film presents auspicious second-order nonlinear optical properties, which achieve the ample nonlinear optical effects about 50 pm/V. Many different deposition methods, such as the sol–gel technique(1-3), sputtering(4), pulsed laser deposition (MOCVD)(11), and chemical vapor deposition (CVD)(12), have been utilized for the growth of ZnO films on distinct substrates. Among these methods Spray pyrolysis, is an astonishing method for the deposition of thin films of metallic oxides. For turning ZnO to an electronic material, doping is the very useful way. Many dopants are taken from rare earth elements and group I and V. From those materials, doping with Al elements can conclude in fascinating optical and electrical properties.

In this work, to upgrade the optoelectronic properties of ZnO thin film, spray pyrolysis is used. Zinc acetate dehydrate, 2 Methoxy ethanol and Monoethanolamine were used as the precursor, solvent and stabilizer respectively. Undoped and aluminium doped zinc oxide (ZnO) thin films have been prepared on glass substrates by spray pyrolysis technique. We have investigated the influence of doping concentrations ranging from 0 to 5 at.-% on optical, and electrical properties of ZnO thin films. This Al content region is ideal for good achievement of *n*-type ZnO.

Experimental details

By spray pyrolysis (SP) technique, Al-doped zinc oxide (AZO) thin films have been prepared of zinc acetate and aluminium nitrate. Zinc acetate dehydrate $(Zn(CH_2COO)_2 \cdot 2H_2O)$ (ZAD) is used as starting material, 2-methoxyethanol (CH₃O (CH₂)2OH) (2-ME) is used as solvent and monoethanolamine ((HOCH₂CH₂) NH₂) (MEA) is used as a stabilizer. The dopant source was aluminum nitrate [Al(NO₃)₂·9H₂O]. Zinc acetate dehydrate (Zn(CH₃COO)₂ 2H₂O) was first dissolved in a mixture of 2-methoxyethanol and MEA solution. The molar ratio of dopant in the starting solution was varied to give a [Al/Zn] ratio of 1-5 at.-%. The molar ratio of MEA to zinc acetate was maintained at 1.0 and the concentration of zinc acetate was 0.6 M/L. The resultant solution was stirred at 60 °C for 2 h to yield a clear and homogeneous solution, which perform as the coating solution after cooling to room temperature. Finally the solution was allowed to age for 24 h at room temperature under constant agitation. The uncoated quartz substrates were carefully cleaned with distilled water, acetone and ethanol in sequence. Then they were rinsed with distilled water and lastly dried with N₂ (99.99999%) gas.

The spray solution was prepared from a 0.1M solution of zinc acetate dehydrate dissolved in mixture of 3:1 isopropyl alcohol and de-ionized water. A small amount of acetic acid was added to increase the solubility of zinc acetate. The films were deposited by spraying 50 ml of the solution through a glass nozzle onto heated glass substrate kept at about 400° C. A PID temperature controller controlled planar heater was used to heat the glass substrates. The compressed air was used as a carrier gas and spray rate of the solution was maintained at 5ml/min. The nozzle to substrate distance was 28 cm and the nozzle oscillated to and from with constant frequency if 30 cycles/min.

Thickness and refractive index of the films are measured by an Ellipsometer (Holmarc opto mechatronics) using DPSS laser (532 nm) beam. The optical absorption-transmission studies were carried out using UV-Vis spectrophotometer (Shimadzu, model UV-1800, Japan) in the wavelength range 300–1100 nm with 0.01 nm resolutions. Resistivity and Hall measurement of the Al doped ZnO thin films are measured by van der Pauw method using Keithley 236 source measure unit. For electrical characterization, high conducting silver paste (Ag) was used to make ohmic contacts on both sides of the ZnO thin films. The contacts were properly heated and allowed to dry.

Results and Discussion

Optical Properties:

The optical transmission was measured by a UV-Vis spectrophotometer. The UV-visible absorption spectra of the Al doped ZnO thin films are shown in Fig. (1) and transmittance spectra are shown in Fig. (2). The fluctuation in the spectra is principally due to the interference effect owing to the reflection at interfaces. Sharp fundamental absorption edges are observed in all the spectra corresponding to the ZnO, AZO films in the range of 0-5 at.-%. These films have a high transmittance about 90% in visible regions and a high absorption near 100% in UV regions.



Fig 1. Absorption spectra of the spray pyrolysis Al doped ZnO thin films



Fig 2. Transmittance spectra of the spray pyrolysis Al doped ZnO thin films

A blue shift in the optical band edge was observed both in optical absorption as well as in transmittance spectra, with Al doping. As shown in Fig (2), the optical transmittance of the films initially increases with increasing Al doping up to 4-5 at.-% and transmittance increases more than 80 % in the visible region. Further increase in Al doping leads to decrease in transmittance. The improvement of transmittance and blue shift in the optical spectra of Al doped ZnO thin films may be due to the presence of Al₂O₃ and Zn-O-Al phases in the thin films, and/or formation of nano-structured films due to Al doping. The decrease in transmittance of the films grown from high atomic percentage of Al may be due to the degradation in the crystallinity of the thin films.

The fundamental absorption which corresponds to the electron excitation from valance band to conduction band is usually used to determine the value of optical band gap. As direct bandgap semiconductor, ZnO has absorption co-efficient (α) obeying the following relation for high photons energies (h γ).

$$\alpha(h\gamma) = c(h\gamma - E_g)^{1/2}$$

Here c is constant and γ is the photon frequency. The absorption coefficient α is defined as .

 $I = I_0 exp(-\alpha t)$

Where I and I_0 are intensities of transmitted and incident light respectively and t is the film thickness. Considering interfaces related to the film and the film thickness in practical experiments, the transmittance (T) and reflectivity R of the film obey the following relation.

$$T = (1-R)^2 \exp(-\alpha t)$$

Thus α could be calculated from the above relation.

$$\alpha = \frac{1}{t \ln(1-R)^2}$$

With increasing Al content from 0 to 4 at.-%, the band gap of AZO films first increases and then decreases. It reached the maximum value of 3.52 eV at 4 at.-% Al, which coincides with the highest electron concentration. The movement of the band gap is explained by the cause of the Burstein-Moss shift^{12,13}, an energy band widening (blue shift) effect resulting from the increase of the Fermi level in the conduction band of degenerate semiconductors.

Electrical Properties

The electrical properties were investigated by Hall effect measurements. The figure (3) shows how the electrical resistivity(ρ), Hall mobility (μ_H) and carrier concentration (n_e) of Al doped ZnO films are related to the Al content ranging from 0 to 5 at.-%. The resistivity is about 70.7 Ω cm for the undoped ZnO film. By introduction of Al in ZnO, the electrical resistivity is greatly reduced. For example, the resistivity is about 1.45 X10⁻³ Ω cm at 1 at.-% Al, and then decreases to 8.21 X 10⁻⁴ Ω cm at 4 at.-% Al, which is the minimum value obtained for AZO films, six orders of magnitude lower than that of undoped samples. As the Al content is up to 5 at.-%, the film resistivity is 3.03X10⁻³ Ω cm. The resistivity of the Al doped ZnO thin film is related to the

Al-doping concentration. The electrical resistivity (ρ) is proportional to the reciprocal of the product of the carrier concentration (n_e) and Hall mobility (μ_H).



Fig. 3. Resistivity of the spray pyrolysis Al-doped ZnO thin films as a function of the Al impurity concentration.

The carrier concentration of Al doped ZnO thin film is shown in figure (4). The electron concentration of undoped ZnO film is about 3.6 $\times 10^{15}$ cm⁻³, which could be enhanced drastically by the Al incorporation. As the Al content increases from 1 to 5 at.-%, the electron concentration first increases and then decreases. The electron concentration reached a maximum value of 6.2 $\times 10^{20}$ cm⁻³ in 4at.-% Al. It is noted that the electron concentrations are always more than 10^{20} cm⁻³ in the 1–5 at.-% doping content range. The above behavior of electron concentration suggests that not all the Al atoms in the film contribute to donor dopants.



Fig. 4. Carrier concentration and Hall mobility of the spray pyrolysis derived Al-doped ZnO thin film as a function of the Al concentration.

Sample	Resistivity ρ (Ω-cm)	Carrier concentration n _e (cm ⁻³)
ZnO	0.1612	$4.05 \ge 10^{16}$
1 % Al:ZnO	0.1794	3.53×10^{16}
2 % Al:ZnO	0.1556	$4.24 \ge 10^{16}$
3 % Al:ZnO	0.1763	3.61 x 10 ¹⁶
4 % Al:ZnO	0.1725	3.71 x 10 ¹⁶
5 % Al:ZnO	0.2119	2.86 x 10 ¹⁶

Table 1 Variation of Resistivity with Carrier concentration in different Al dopant levels

Conclusion

Aluminium doped ZnO thin films with hexagonal wurtzite type polycrystalline structure and good optical quality have been prepared on glass substrates by spray pyrolysis in a range of Al content from 0 to 5 at.-%. The Al doped ZnO films were systematically examined for having a comprehensive knowledge of their behaviors. The growth rate of ZnO films is monotonically reduced with increasing Al content. From the above studies The crystalline quality of the grown thin films gets degraded as the Al doping is increased. The transmittance of the film prepared from spray solutions with Al atomic percentage up to around 5% was improved from that of undoped ZnO films. All the films exhibit high transmittance (91% - 95%) in the range of 400 nm to 800 nm, thus making the films suitable for optoelectronic devices, for instance as window layers in solar cells. The film has the strong emission band at 383 nm and also a broad emission peak centred at 550 nm visible regions.From the above results, we considered that these films are potentially attractive to be applied as transparent conductors in thin film solar cells. In addition to that the recent success in creating p-type conductivity in ZnO makes it very promising for use in ultraviolet UV and blue optoelectronic devices such as light-emitting diodes LEDs and laser diodes LDs. Al doped ZnO thin films are examined commonly as an optimal n-type layer for the hetero structure device design.

References

- 1. D. Bao, H. Gu, and A. Kunag, "Sol-gel derived C-axis oriented ZnO thin films," *Thin solid films*, 1998, 312, 37-39.
- 2. G. Srinivasan, N. Gopalakrishnan, Y. S. Yu, R. Kesavamoorthy, and J. Kumar, "Influence of postdeposition annealing on the structural and optical properties of ZnO thin films prepared by sol-gel and spin-coating method," *Superlattices and Microstructures*, 2008, 43, 112–119.
- 3. C. J. Brinker, G. C. Frye, A. J. Hurd, and C. S. Ashley, "Fundamentals of sol-gel dip coating," *Thin Solid Films*, 1991, 201, 97–108.
- 4. S. Eisermann, J. Sann, A. Polity, and B. K. Meyer, "Sputter deposition of ZnO thin films at high substrate temperatures," *Thin Solid Films*, 2009, 517, 5805–5807.
- 5. M. Rusop, K. Uma, T. Soga, and T. Jimbo, "Post-growth annealing of zinc oxide thin films pulsed laser deposited under enhanced oxygen pressure on quartz and silicon substrates," *Materials Science and Engineering B*, 2006, 127, 150–153.
- 6. A. L. Mercado, C. E. Allmond, J. G. Hoekstra, and J. M. FitzGerald, "Pulsed laser deposition vs. matrix assisted pulsed laser evaporation for growth of biodegradable polymer thin films," Applied Physics A, vol. 81, no. 3, pp. 591–599, 2005.
- 7. D. C. Look, D. C. Reynolds, C. W. Litton, R. L. Jones, D. B.Eason, and G. Cantwell, "Characterization of homo epitaxial ptypeZnO grown by molecular beam epitaxy," *Applied Physics Letters*, 2002, 81, 1830–1832.
- 8. D. Perednis and L. J. Gauckler, "Thin film deposition using spray pyrolysis," *Journal of Electroceramics*, 2005, 14, 103–111.
- 9. M. Krunks and E. Mellikov, "Zinc oxide thin films by the spray pyrolysis method," *Thin Solid Films*, 1995, 270, 33–36.
- 10. O. Vigil, F. Cruz, A. Morales-Acevedo, G. Contreras-Puente, L.Vaillant, and G. Santana, "Structural and optical properties of annealed CdO thin films prepared by spray pyrolysis," *Materials Chemistry and Physics*, 2001, 68, 249–252.
- 11. Jungyol Jo, Ogweon Seo, Hyoshik Choi, Byeonggon Lee, "Enhancement-Mode ZnO Thin-Film Transistor Grown by Metal organic Chemical Vapor Deposition," *Appl. Phys. Express,* 2008, 1, 041202.
- 12. Moss T.S., "The Interpretataion of the Properties of Indium Antimonide", *Proc. Phys.Soc.Lond. B*, 1954, 67, 775-782.